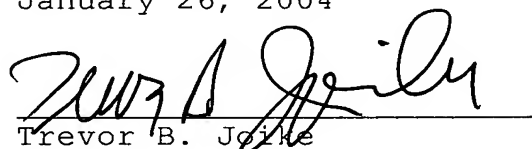


IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants:	M. A.)	I hereby certify that this
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)	VA 22313-1450 on this date:
Filed:)	
)	January 26, 2004
Probable Group Art Unit:)	
2814)	
Probable Examiner:	S.)	Trevor B. Joine
H. Rao)	Reg. No. 25,542
)	Attorney for Applicants

PRELIMINARY AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTION

Claims 1-6 and 22-31 remain in the application.
Claims 7-21 are cancelled.